Docket No.: 49959-167

**PATENT** 

VECHNOLOGY CLUTER 2800

## PATENT AND TRADEMARK OFFICE IN THE UNITED

In re Application of

Gilad ALMOGY, et al.

Serial No.: 09/641,137

Filed: August 16, 2000

VARIABLE ANGLE ILLUMINATION WAFER INSPECTION SYSTEM For:

Group Art Unit: 2877

Examiner: Unassigned

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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